

Fig. 1

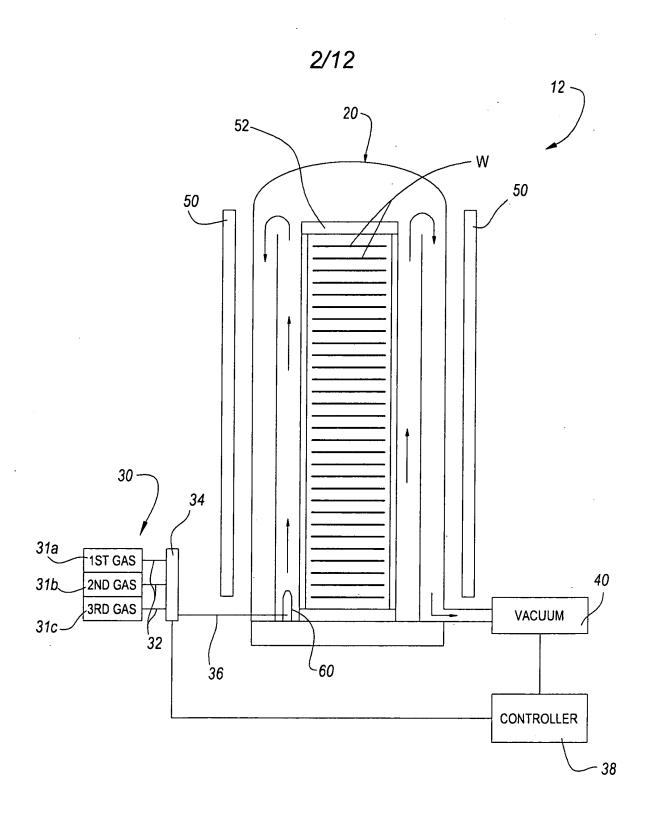


Fig. 2

<u>Attorney Docket:</u> 10829.8714US <u>First Inventor:</u> Zheng <u>Title:</u> Methods For Forming Small-Scale Capacitor Structures

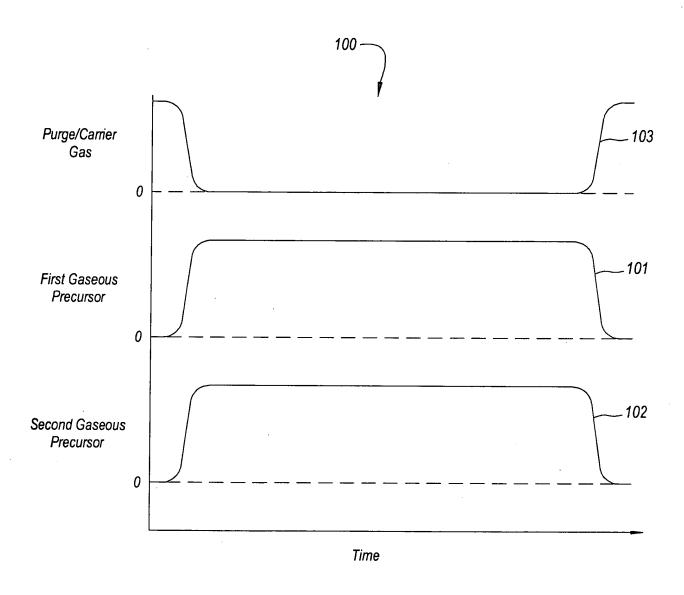
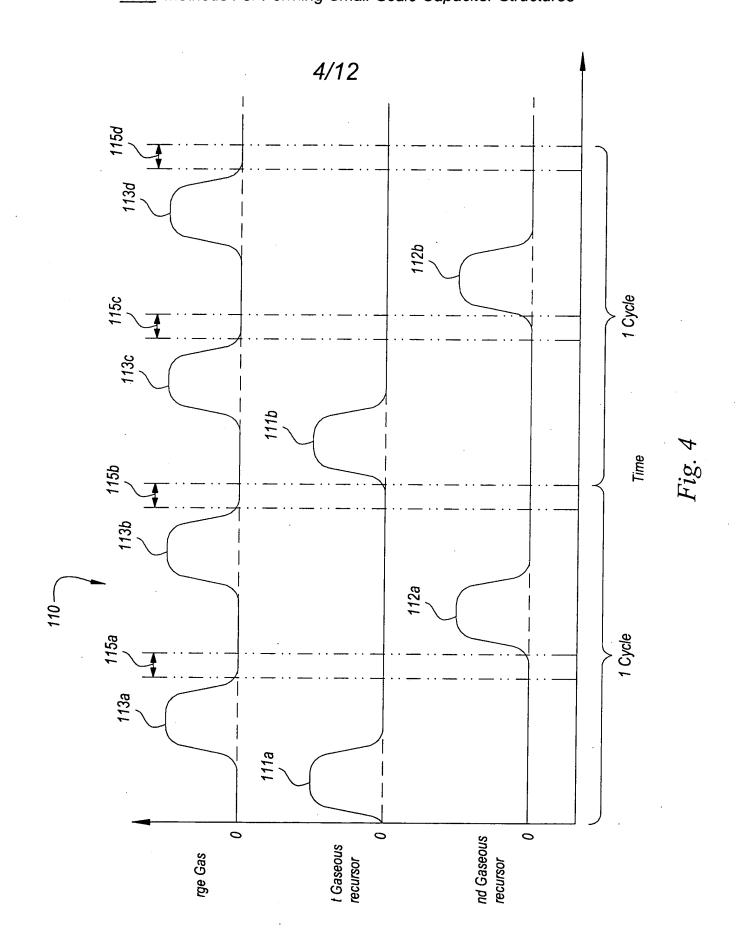
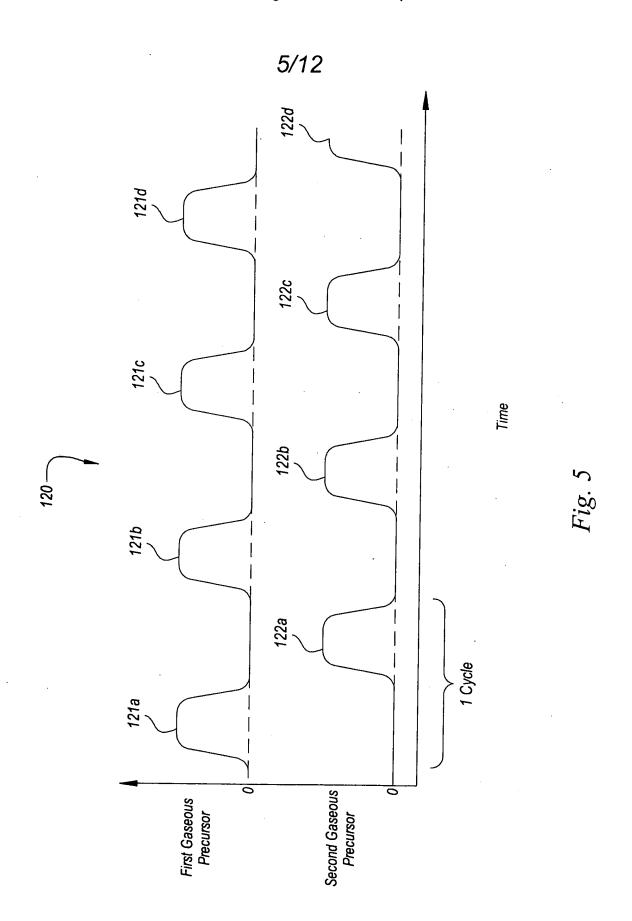
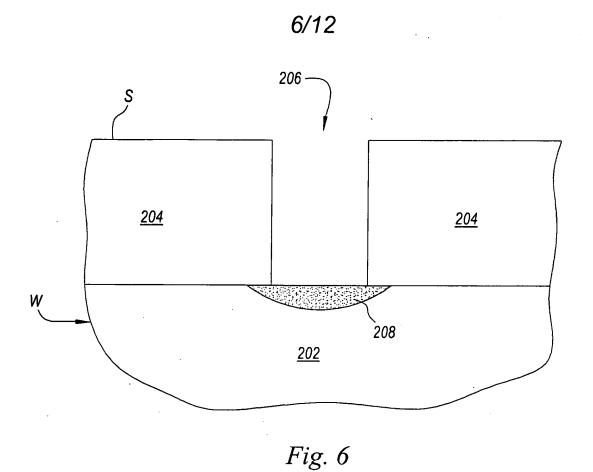


Fig. 3





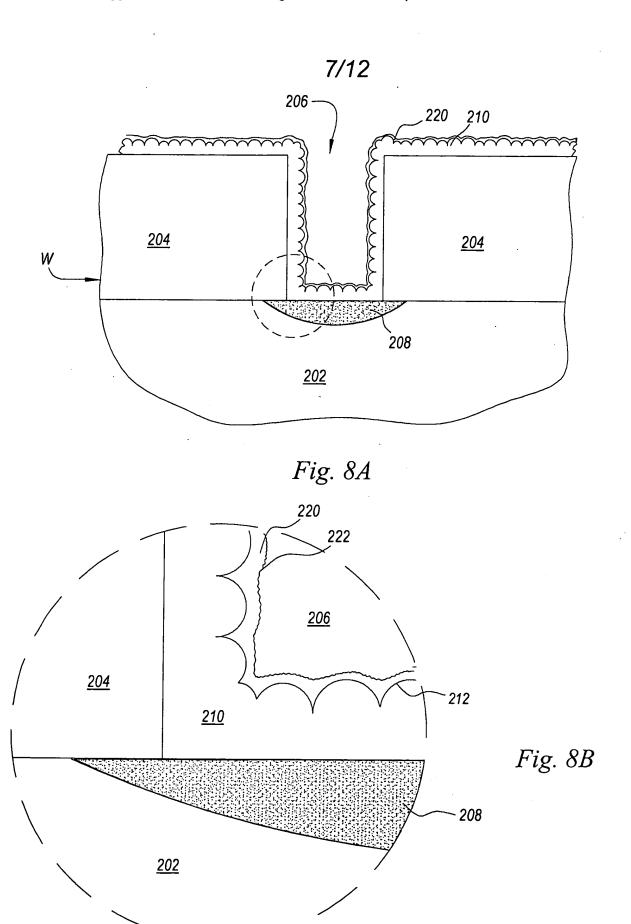
<u>Attorney Docket:</u> 10829.8714US <u>First Inventor:</u> Zheng <u>Title:</u> Methods For Forming Small-Scale Capacitor Structures

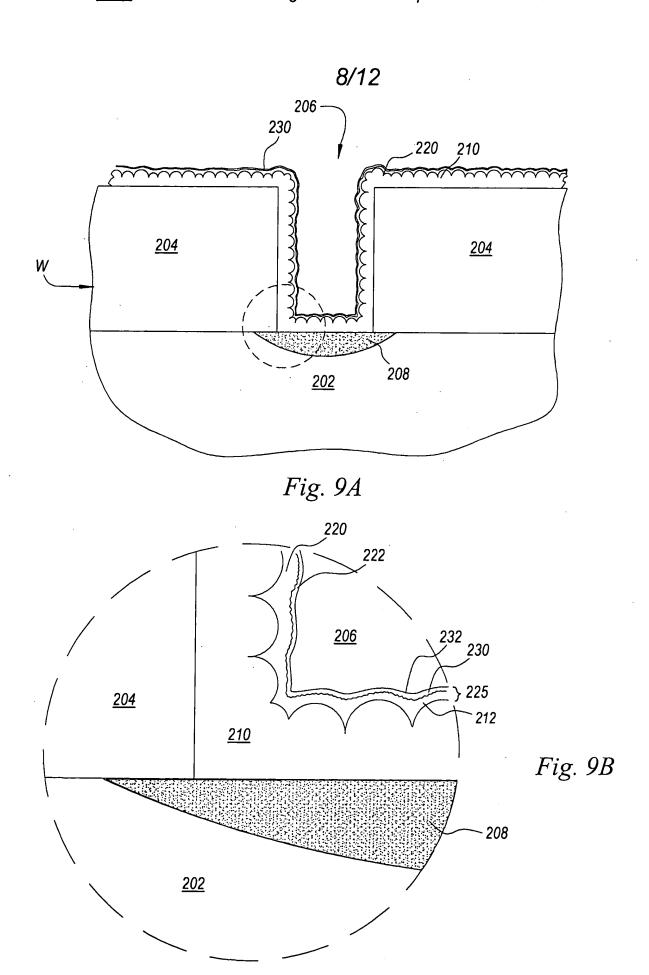


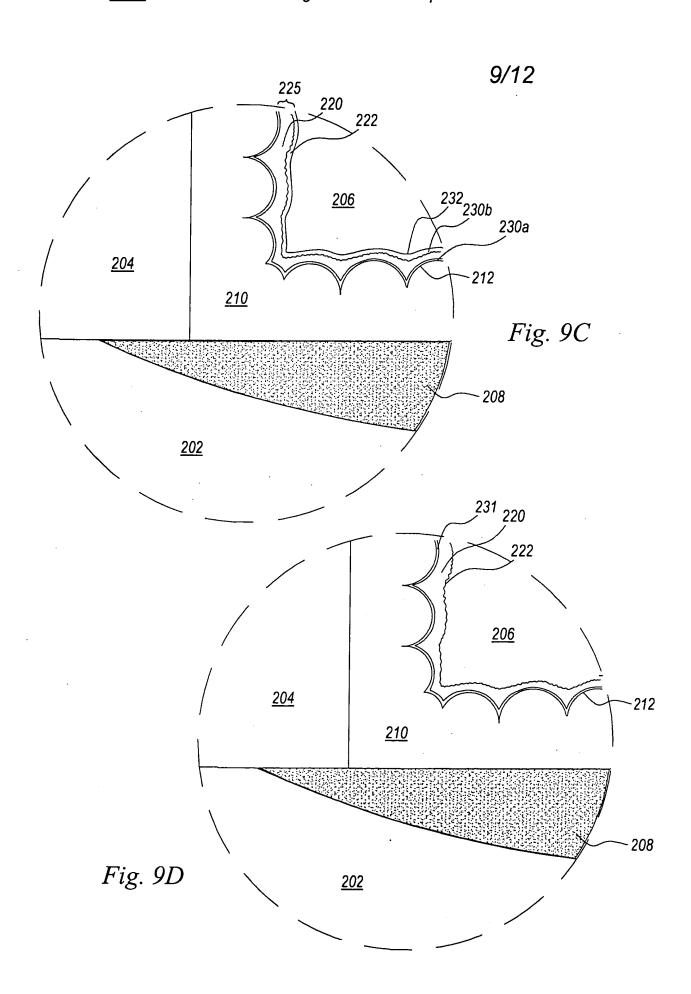
206 212 210 204 204

Fig. 7

<u> 202</u>







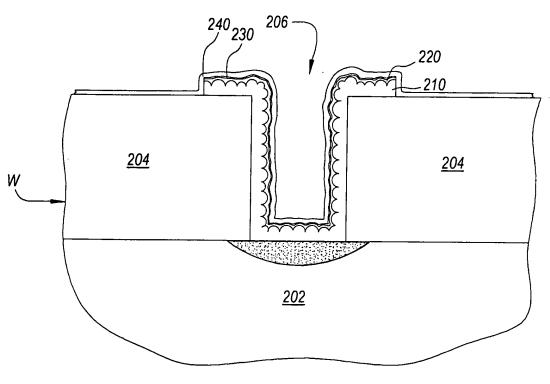


Fig. 10

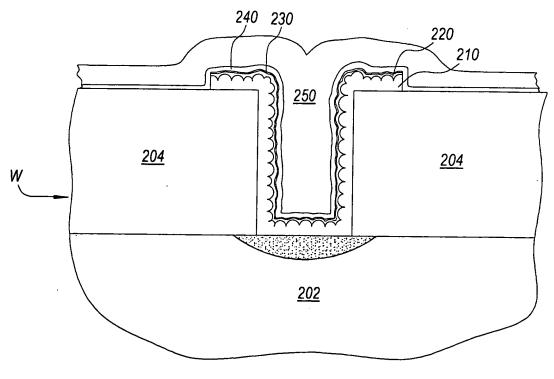
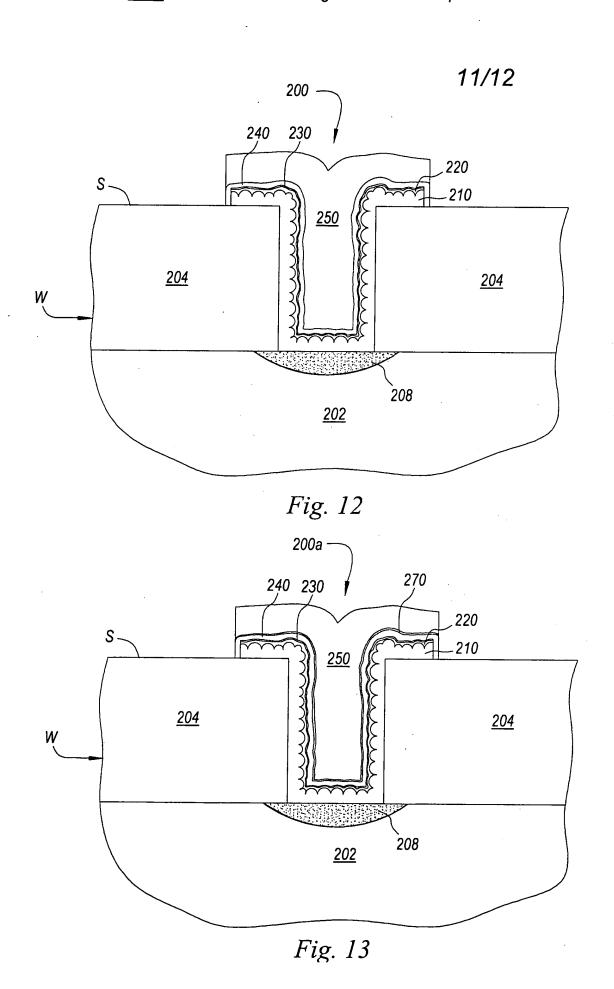


Fig. 11



<u>Attorney Docket:</u> 10829.8714US <u>First Inventor:</u> Zheng <u>Title:</u> Methods For Forming Small-Scale Capacitor Structures

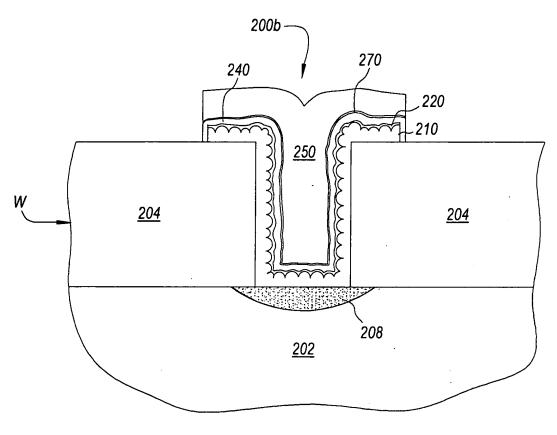


Fig. 14